

MODEL **1040** NanoMill® TEM Specimen Preparation System

The NanoMill system uses an ultra-low energy, concentrated ion beam to produce the highest quality specimens for transmission electron microscopy.

Model 1040 NanoMill® TEM Specimen Preparation System Specifications		
lon source	Filament-based ion source combined with electrostatic lens system	
	Variable voltage (50 eV to 2 kV), continuously adjustable	
	Beam current density up to 1 mA/cm ²	
	Beam diameter as small as 1 µm at 2,000 eV	
	Faraday cup for ion beam current monitoring with a range of 1 to 2,000 pA	
	Field-replaceable apertures	
Specimen stage	Load lock allows specimen exchange in less than 10 seconds	
	Transfer rod for specimen exchange	
	Milling angle range of -12 to $+30^{\circ}$	
Vacuum system	Turbomolecular drag pump backed by an oil-free diaphragm pump	
	Chamber vacuum measurement with a combination cold cathode and Pirani gauge with a range of atmosphere to 1 x 10 ⁻⁸ mbar	
	System base vacuum of 3 x 10 ⁻⁷ mbar	
	Operating vacuum of 1 x 10 ⁻⁴ mbar	
Gas	Automated using mass flow control technology	
	Flow rate up to 2 sccm	
	Integral particulate filter	
	Inert gas (argon) with recommended purity of 99.999%	

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Specimen targeting	Ion beam capable of being targeted at one spot on the specimen surface or scanned within a selected area	
User interface	Menu-driven interface	
	Programmable milling cycles with system status displayed	
Chamber illumination	User-controlled chamber illumination to facilitate specimen exchange	
Specimen cooling	Liquid nitrogen conductive cooling with automatic temperature interlocks	
	Stage temperature to -170 °C	
	System cool-down time less than 20 minutes	
	Specimen cool-down time less than 5 minutes	
	Dewar hold time up to 6 hours	
	Integral load lock heater ensures rapid specimen warming times to ambient temperature	
Automatic termination	Process termination by time or temperature	
Imaging	SED-based imaging technology	
	3 mm field of view	
	Everhart-Thornley detector	
	Specimen image displayed on graphical user interface	
Dimensions	39 in (991 mm) width x 58 in (1,474 mm) height x 31 in (788 mm) depth	
Weight	507 lb (230.5 kg)	
Power	110/220 V AC, 50/60 Hz, 1,000 W	
Warranty	One year	
Service contract	Available upon request	



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